

Conf A1

This application is related to U.S. patent application serial number 09/676,375 (Attorney Docket 50275-0015), entitled "Dissection Of Printed Edges From A Fabrication Layout For Correcting Proximity Effects," filed on September 29, 2000, invented by Christophe Pierrat and Youping Zhang.

This application is related to U.S. patent application serial number 09/676,356 (Attorney Docket 50275-0016), entitled "Selection Of Evaluation Point Locations Based on Proximity Effects Model Amplitudes For Correcting Proximity Effects In A Fabrication Layout," filed on September 29, 2000, invented by Christophe Pierrat and Youping Zhang.

This application is related to U.S. patent application serial number 09/728,885 (Attorney Docket 50275-0017), entitled "Displacing Edge Segments On A Fabrication Layout Based on Proximity Effects Model Amplitudes For Correcting Proximity Effects," filed on December 1, 2000, invented by Christophe Pierrat and Youping Zhang.

This application is related to U.S. patent application serial number 09/130,996, entitled "Visual Inspection and Verification System," filed on August 7, 1998.

This application is related to U.S. patent application serial number 09/153,783, entitled "Design Rule Checking System and Method," filed on September 16, 1998.

This application is related to U.S. patent application serial number 09/544,798, entitled "Method and Apparatus for a Network Based Mask Defect Printability Analysis System," filed on April 7, 2000.

This application is related to U.S. patent application serial number 09/154,415, entitled "Data Hierarchy Layout Correction and Verification Method and Apparatus," filed on September 16, 1998.

This application is related to U.S. patent application serial number 09/154,397, entitled "Method and Apparatus for Data Hierarchy Maintenance in a System for Mask Description," filed on September 16, 1998.